

1. Record Nr.	UNINA9910172653203321
Titolo	2016 14th International Baltic Conference on Atomic Layer Deposition (BALD) // Institute of Electrical and Electronics Engineers (IEEE)
Pubbl/distr/stampa	Piscataway, New Jersey : , : Institute of Electrical and Electronics Engineers (IEEE), , 2016
ISBN	1-5090-3416-1
Descrizione fisica	1 online resource (various pagings) : illustrations
Disciplina	621.381
Soggetti	Atomic layer deposition Electronics
Lingua di pubblicazione	Inglese
Formato	Materiale a stampa
Livello bibliografico	Monografia
Sommario/riassunto	BALD 2016 will provide possibilities to publish results of recent studies on atomic layer deposition (ALD) and to initiate and support collaboration between research groups working in this field and applications from advanced electronics, microsystems, and displays to energy capture and storage, solid state lighting, biotechnology, security, and consumer products particularly for any advanced technologies that require control of film structure in the nanometer or sub nanometer scale.